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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/788,670	02/27/2004	John T. Strom	044182/308512	3585	
7590 10/05/2004 Intellectual Property Group of Pillsbury Winthrop LLP Suite 200			EXAMINER		
			NGUYEN, JIMMY		
			ART UNIT	PAPER NUMBER	
11682 El Camin		2829			
San Diego, CA 92130			DATE MAILED: 10/05/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

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Office Action Summary		Applica	tion No.	Applicant(s)			
		10/788,	670	STROM, JOHN T.			
		Examin	er	Art Unit			
		Jimmy		2829			
Period f	The MAILING DATE of this commun or Reply	ication appears on t	he cover sheet w	ith the correspondence addres	SS		
THE - Exte after - If th - If NO - Failt Any	MAILING DATE OF THIS COMMUN insions of time may be available under the provisions SIX (6) MONTHS from the mailing date of this comme period for reply specified above is less than thirty (3) period for reply is specified above, the maximum starre to reply within the set or extended period for reply reply received by the Office later than three months are part of the provision of	ICATION. of 37 CFR 1.136(a). In no on the control of the control o	event, however, may a tatutory minimum of thi will expire SIX (6) MOI pplication to become A	reply be timely filed rty (30) days will be considered timely. NTHS from the mailing date of this commu BANDONED (35 U.S.C. § 133).	ınication.		
Status							
1) 又	Responsive to communication(s) file	ed on <i>27 February 2</i>	2004.	,			
2a)□	This action is FINAL . 2b)⊠ This action is non-final.						
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
5)□	Claim(s) 1 is/are pending in the app 4a) Of the above claim(s) is/a Claim(s) is/are allowed. Claim(s) 1 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restrict	re withdrawn from o					
Applicat	ion Papers						
	The specification is objected to by the The drawing(s) filed on is/are Applicant may not request that any objections.	a) accepted or					
11)	Replacement drawing sheet(s) including The oath or declaration is objected to	the correction is requ	uired if the drawing	g(s) is objected to. See 37 CFR 1			
Priority	under 35 U.S.C. § 119						
a)	Acknowledgment is made of a claim All b) Some * c) None of: 1 Certified copies of the priority 2. Certified copies of the priority 3. Copies of the certified copies application from the Internation	documents have be documents have be of the priority docur anal Bureau (PCT R	een received. een received in A ments have beer ule 17.2(a)).	Application No n received in this National Sta	ge		
Attachmer	nt(s) ce of References Cited (PTO-892)		A) Interview	Summary (PTO-413)			
2)	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (F mation Disclosure Statement(s) (PTO-1449 or er No(s)/Mail Date		Paper No	(s)/Mail Date Informal Patent Application (PTO-152	2)		

DETAILED ACTION

Claim objection

As to claim 1, the description of the specification is not disclosed anything about a data processor coupled to imaging apparatus. Clarification is required.

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

2. Claim 1 is rejected under 35 U.S.C. 102(b) as being anticipated by Schwartz et al (US 5657394).

As to claim 1, Schwartz et al disclose (fig 4) an opto-mechanical workstation (100) for loading (the wafer), systemically moving (X, Y direction), imaging (124) and analyzing (column 9 line 24 –34) scrub marks, workstation comprising;

A probe card analyzer (99);

A scrub mark analyzer (200);

An imaging apparatus (146) configured and operative to obtain images of first scrub marks made by probe card pins (60) on a check plate in probe card analyzer (99) and images of second scrub marks med by probe card pins (60) on bonding pad in scrub mark analyzer (200, as seen in claim 1); and

A data processor (200) coupled to imaging apparatus (146) and configured and operative to obtain scrub mark data associated with first scrub marks and scrub pattern

Application/Control Number: 10/788,670

Art Unit: 2829

Page 3

data associated with second scrub marks and to analyze scrub mark data and scrub pattern

data; wherein data processor allows prediction of the behavior of a probe pin on a

semiconductor device metalization pad (claim 1 of the "394 patent)

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Jimmy Nguyen at (703) 306-5858. Any inquiry of a

general nature of relating to the status of this application or proceeding should be

directed to the Group receptionist whose telephone number is (703) 305-4900.

JN.

October 29, 2004

Michael Tokar

Supervisory Patent Examiner Technology Center 2800